



JRW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8585**
Takashi OHSAKO et al. : Attorney Docket No. 2003_1364A
Serial No. 10/677,221 : Group Art Unit 2823
Filed October 3, 2003 : Examiner Joannie Garcia

METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated May 17, 2006, please amend the above-identified application as follows.